



4319.70023

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shin Ohnuki

)
I hereby certify that this paper is being deposited with the
United States Postal Service as FIRST-CLASS mail in an
envelope addressed to: Mail Stop RCE, Commissioner for
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Serial No.: 10/796,344

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Conf. No.: 1978

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Date
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Appr. February 20, 1998

For: VACUUM PROCESSING
APPARATUS

Art Unit: 1763

Examiner: Lund, Jeffrie Robert

AMENDMENT D

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed October 10, 2007, please
amend the application as follows: